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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Inventor(s): Stephen P. DeOrnellas et al.  
SC/Serial No.: 10/045,318  
Confirm. No.: 3120  
Filed: November 9, 2001  
Title: METHOD FOR USING A HARD  
MASK FOR CRITICAL  
DIMENSION GROWTH  
CONTAINMENT

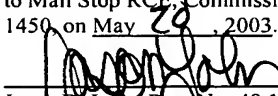
PATENT APPLICATION

Art Unit: 1765  
Examiner: L. Umez-Eronini

Customer No. 23910

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8**

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop RCE, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on May 29, 2003.

  
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Jason D. Lohr, Reg. No. 48,163  
Signature Date: May 29, 2003

(Attorney Signature)

**RESPONSE "B" TO OFFICE ACTION UNDER 37 C.F.R. § 1.116**

Mail Stop RCE  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This RESPONSE B is in reply to the Office action mailed November 22, 2002. No fee is due for the addition of new claims. An appropriate Petition for Extension of Time to Respond is submitted herewith, together with the appropriate fee.

**Amendments**

Please amend the above-identified application as follows: